

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	
Nobuo SHIMAZU et al.) Group Art Unit: 288	1
Application No.: 09/732,928) Examiner: J.P. Hugh	ıes
Filed: December 11, 2000) Confirmation No. 23	05
For: ELECTRON BEAM PROXIMITY EXPOSURE APPARATUS AND MASK UNIT THEREFOR	;) ;	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December

3.M. Mo Manus

<u>AMENDMENT</u>

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following is presented in response to the Examiner's Office Action dated September 30, 2003, in connection with the above captioned patent application..